

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kobayashi, Migaku

Serial No.: 10/060,569

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Title: METHOD OF FABRICATING A
SEMICONDUCTOR DEVICE

Attorney Docket No.: N230500C1

Group Art Unit: 1763

Examiner: Goudreau, George A.

#8
10/24/02
mw

RESPONSE TO OFFICE ACTION

5 Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

10 The following is submitted in response to the Office Action dated July 31, 2002, and is
currently due October 31, 2002.OFFICIAL
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37 C.F.R. §1.8

I hereby certify that this correspondence is being

30 [X] transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9310
Date of Transmittal: October 28, 200235 [] deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for
Patents, Washington, D.C. 20231.

Date of Deposit: _____

40 Typed/Printed Name: Bradley T. SakoSignature: 